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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



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Daryl A. Albus
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Applicant : Brian D. Hunt, et al.
Application No. : 10/052,302
Filed : January 18, 2002
Title : CARBON NANOBIMORPH ACTUATOR AND SENSOR
Grp./Div. : 2834
Examiner : to be assigned
Docket No. : 47489/RAG/C766

INFORMATION DISCLOSURE STATEMENT
37 CFR § 1.97(b)

Assistant Commissioner for Patents
Washington, D.C. 20231

Post Office Box 7068
Pasadena, CA 91109-7068
June 25, 2002

Commissioner:

In compliance with the duty of disclosure under 37 CFR §§ 1.56, 1.97 and 1.98, and in accordance with the provisions in the Manual of Patent Examining Procedure §§ 609 and 707.05(b), enclosed is FORM PTO/SB/08A/B listing the references that are known to applicant. Copies of each of the listed references are enclosed. This filing is timely because it is made during one of the periods described in 37 CFR § 1.97(b).

It is respectfully requested that the listed references be considered in the examination of this application and identified on the list of references cited on the patent issuing for this application. Applicant also requests that an initialed copy of FORM PTO/SB/08A/B be entered in the application file and returned to applicant with the next communication from the Office in accordance with MPEP § 609.

Respectfully submitted,
CHRISTIE, PARKER & HALE, LLP

By *John W. Peck*
John W. Peck, Ph.D.
Reg. No. 44,284
626/795-9900

JWP/daa
Enclosures: PTO/SB/08A/B, w/references
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FORM PTO/SB/08A/B (10-01)
Substitute for PTO-1449A/B

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Attorney Docket Number

47489/JWP/0166

Application Number

10/052,302

Filing Date

January 18, 2002

Applicant(s)

Brian D. Hunt et al.

Group Art Unit

2834

Examiner Name

to be assigned

U.S. PATENT DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	DOCUMENT NUMBER Number - kind code ² . (If known)	PUBLICATION DATE MM-DD-YYYY	NAME OF PATENTEE
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		5,837,115	11-17-1998	Austin et al.

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EXAMINER INITIALS	Cite No. ¹	Foreign Patent Document Country Code ³ - Number ⁴ - Kind Code ⁵ (If known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T ⁶ (✓)

OTHER DOCUMENTS

EXAMINER INITIALS	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
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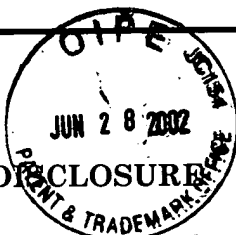
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Attorney Docket Number	47489/JWP/C766
Application Number	10/052,302
Filing Date	January 18, 2002
Applicant(s)	Brian D. Hunt
Group Art Unit	2834
Examiner Name	to be assigned

OTHER DOCUMENTS

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Attorney Docket Number	47489/JWP/C766
Application Number	10/052,302
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Applicant(s)	Brian D. Hunt et al.
Group Art Unit	2834
Examiner Name	to be assigned

OTHER DOCUMENTS

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INFORMATION DISCLOSURE

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Attorney Docket Number 47489/JWP/C796
Application Number 10/052,302
Filing Date January 18, 2002
Applicant(s) Brian D. Hunt et al.
Group Art Unit 2834
Examiner Name to be assigned

OTHER DOCUMENTS

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Attorney Docket Number	41285/JWP/C766
Application Number	09/791,493
Filing Date	February 22, 2001
Applicant(s)	Flavio Noca et al.
Group Art Unit	1743
Examiner Name	to be assigned

OTHER DOCUMENTS

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